Electronic Acknowledgement Receipt				
EFS ID:	1328015			
Application Number:	09544801			
International Application Number:				
Confirmation Number:	1717			
Title of Invention:	Semiconductor device and method for fabricating the same			
First Named Inventor/Applicant Name:	Shunpei Yamazaki			
Correspondence Address:	Cook Alex McFarron Manzo Cummings & Mehler LTD - 200 West Adams Street Suite 2850 - Chicago IL 60606 US (312)236-8500 -			
Filer:	Mark James Murphy/Elizabeth Ortiz			
Filer Authorized By:	Mark James Murphy			
Attorney Docket Number:	SEL 174			
Receipt Date:	21-NOV-2006			
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Time Stamp:	15:55:00			
Application Type:	Utility			
Payment information:				

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Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)		
1	Amendment - After Non-Final Rejection	Response.pdf	60069	no	3		
Warnings:							
Information:							
Total Files Size (in bytes):		60069					

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.